

Inventor(s): Ke
Serial No.: To Be Assigned
Filed: Herewith
For: Reducing Photoresist Shrinkage Via Plasma Treatment
Attorney Docket No.: 67,200-641

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FIG 1A

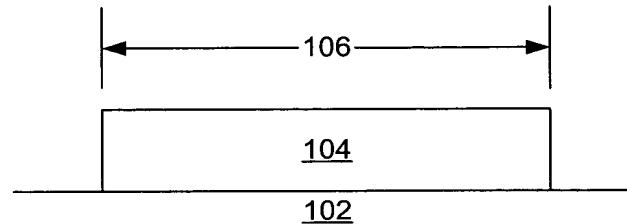


FIG 1B

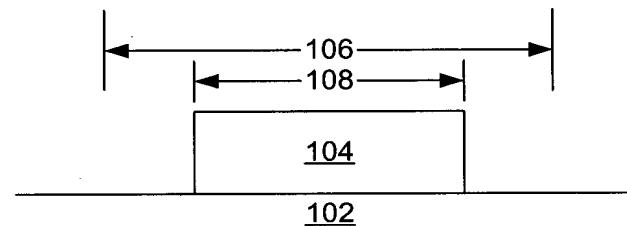


FIG 1C

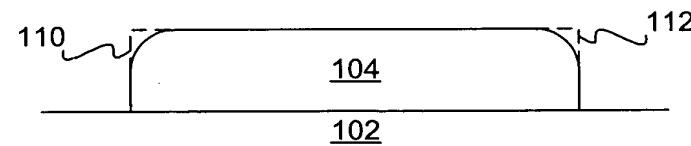
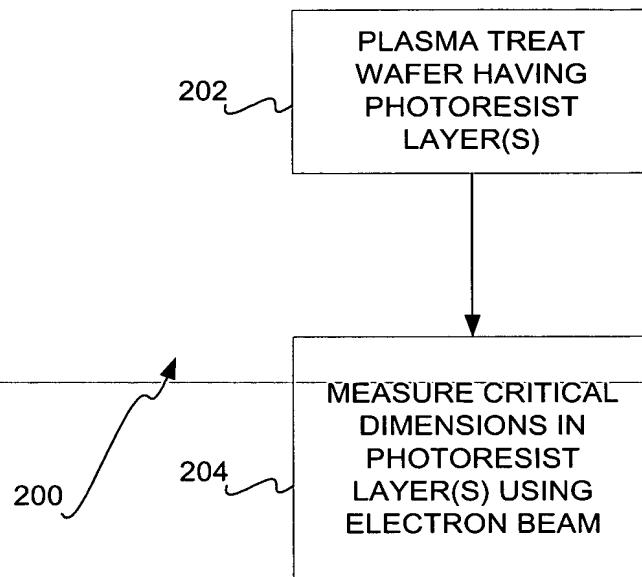
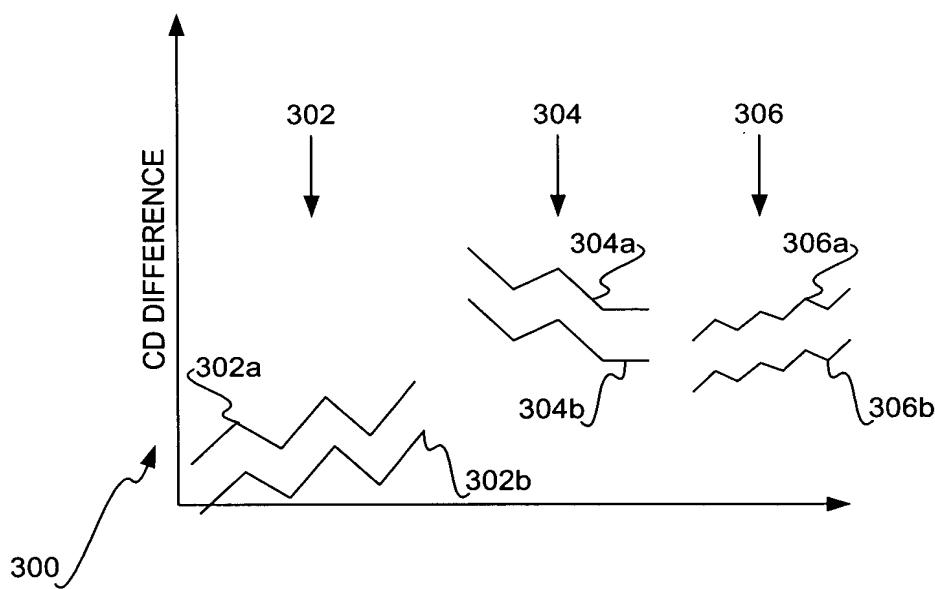


FIG 2



200 204 202 206 208

FIG 3



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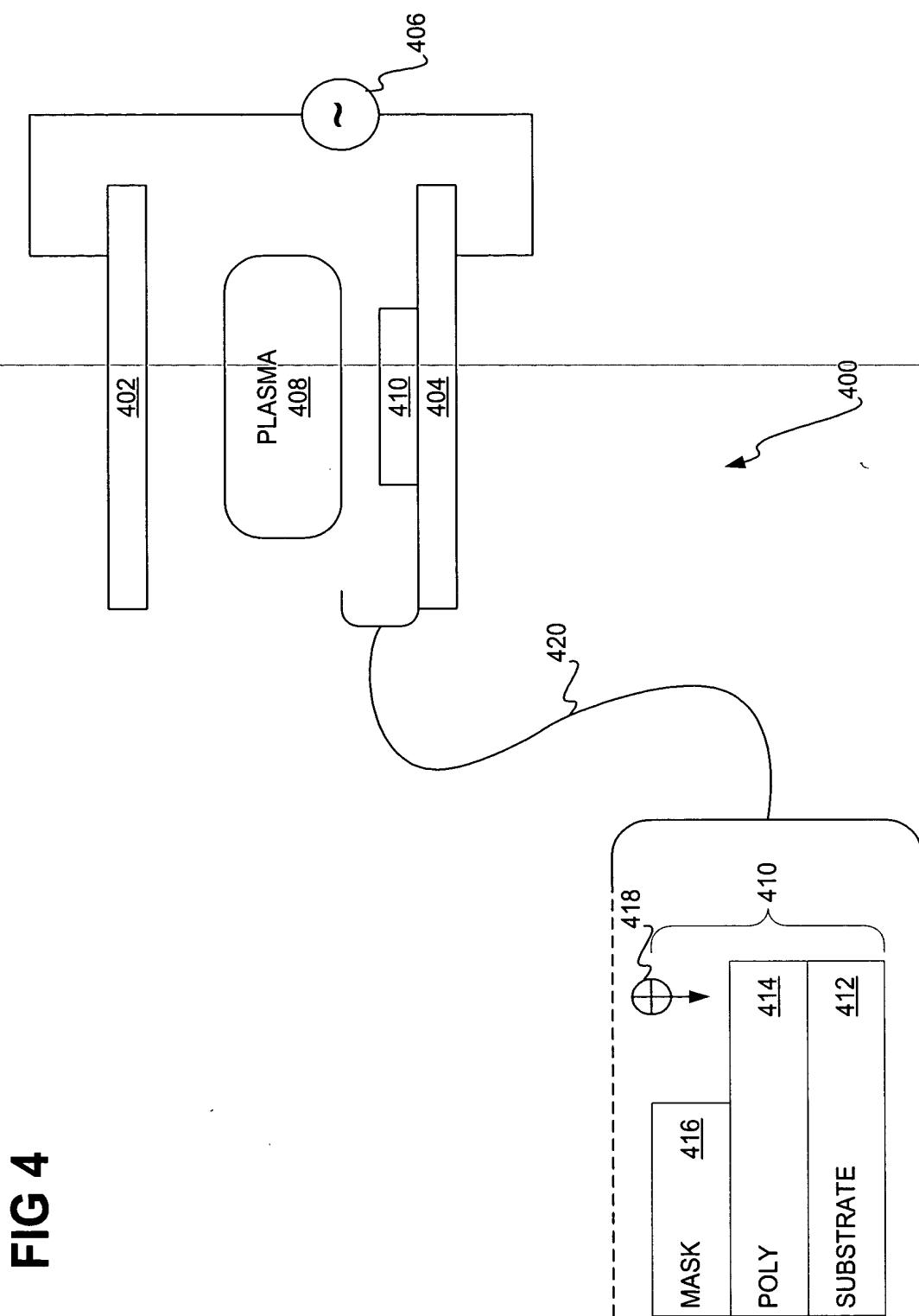


FIG 4